

Form PTO-1449 (Rev. 8-83)		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket N. 0756-2203		Serial No. 09/583087	
RECEIVED INFORMATION DISCLOSURE STATEMENT SEP 05 2000 (Use several sheets if necessary)				Applicant: Shunp i YAMAZAKI			
				Filing Date: September 5, 2000		Group:	
OFFICE OF PETITIONS U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)	
3/06	5,250,931*	10/1993	Misawa et al.				
	5,261,156*	11/1993	Mase et al.				
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Examiner J. Jordan			Date Considered 10/01				
*EXAMINER: Initial citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
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Attorney Docket No. 0756-2303

Serial No. 09/583087

INFORMATION DISCLOSURE STATEMENT

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Applicant: Shumpei YAMAZAKI

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OFFICE OF PETITIONS
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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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Examiner <i>J. J. Johnson</i> Date Considered 10/01						

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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				Applicant: Shumpei YAMAZAKI			
				Filing Date: September 5, 2000		Group:	
OFFICE OF PETITIONS FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
4	3-290924*	12/1991	JP			Abstract	
	3-246973	11/05/91	JP			Abstract	
	4-245655	09/02/92	JP			Abstract	
	92-18644	10/22/92	Korea				X
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	6-88971*	03/1994	JP			Abstract	
	2-208635*	08/1998	JP			Abstract	
		08/20/90					
Examiner <i>J. Mahon</i>				Date Considered 10/01			
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Form PTO-1449 (Rev. 8-83)		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket No. 0756-2230	Serial No. 09/583087
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				Applicant: Shunpei YAMAZAKI	
				Filing Date: September 5, 2000	
OFFICE OF PETITIONS				Group:	
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*Reference cited in parent application S.N. 08/962,601					